

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re <b>Patent</b> Application of:	)
Hidekazu MIYAIRI et al	) Attn: Applications Branch
Serial No. Not Yet Assigned	) Group Art Unit: Not Yet Assigned
Filed: September 17, 2003	)
For: LASER APPARATUS, LASER IRRADIATION	)
METHOD, AND MANUFACTURING METHOD OF	) Date: September 17, 2003
SEMICONDUCTOR DEVICE	)

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

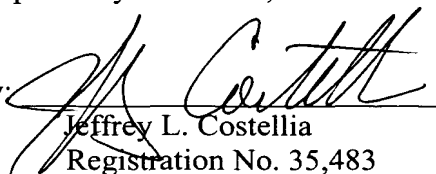
In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98. Pursuant to 37 C.F.R. § 1.98, copies of the documents cited is enclosed for the above-captioned patent application.

It is requested that the accompanying PTO-1449 be considered and made of record in the above-identified application. To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

The Commissioner is hereby authorized to charge any fees connected with this filing which may be required now, or credit any overpayment to Deposit Account No. 19-2380.

Respectfully submitted,

By:

  
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FOREIGN PATENT DOCUMENTS									
Examiner Initials <sup>2</sup>	Cited No.	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>	
		Office <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>5</sup> (if known)					
		JP	07-038180	A	02/07/1995			W/Abstract and Full Translation	
Examiner Signature						Date Considered			

<sup>1</sup> Unique citation designation number. <sup>2</sup> See attached Kinds of U.S. Patent Documents. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language Translation is attached.

NVA277108.1